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Contactless electroreflectance study of the Fermi level pinning on GaSb surface in n-type and p-type GaSb Van Hoof structures


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Contactless electroreflectance (CER) has been applied to study the Fermi-level position on GaSb surface in n-type and p-type GaSb Van Hoof structures. CER resonances, followed by strong Franz-Keldysh oscillation of various periods, were clearly observed for two series of structures. This period was much wider (i.e., the built-in electric field was much larger) for n-type structures, indicating that the GaSb surface Fermi level pinning position is closer to the valence-band than the conduction-band. From analysis of the built-in electric fields in undoped GaSb layers, it was concluded that on GaSb surface the Fermi-level is located ~0.2 eV above the valence band. © 2012 American Institute of Physics. [http://dx.doi.org/10.1063/1.4770413]

I. INTRODUCTION

GaSb is one of the crucial constituents for 6.1 Å lattice system based electronic devices including high electron mobility transistors and semiconductor lasers operating in mid infrared spectral region. One of the fundamental properties affecting the practical applications is the Fermi-level pinning at the (100) GaSb surface (i.e., the surface potential barrier), which is responsible for the formation of Schottky or Ohmic contacts and other phenomena in semiconductor devices. Usually, the surface potential barrier is estimated from electrical measurements using I-V or C-V characteristics of the metal/semiconductor interface. However, the accuracy and reproducibility of this approach are limited because formation of a metal contact on the semiconductor surface influences the surface morphology and thus also the Fermi-level position. Therefore, in order to determine the Fermi-level pinning on a clear semiconductor surface, contactless methods are required.

Contactless electroreflectance (CER) is known as a very powerful method to determine the Fermi-level position in semiconductor structures, including the Fermi-level pinning at the semiconductor surface. So far, there is only a limited number of studies using this technique to investigate GaSb-based heterostructures, and it has not yet been applied to study the Fermi-level pinning at the surface of GaSb material. So far, the issue of Fermi-level position in GaSb system was investigated mostly for metal/GaSb or dielectric/GaSb interface. Our method provides a unique opportunity to determine the Fermi level pinning position on a free surface of GaSb.

II. EXPERIMENT

In order to investigate the surface potential barrier for (100) plane of GaSb, n-type and p-type GaSb Van Hoof structures were grown on (100) GaSb substrates. The surface potential barrier has been determined analyzing the built-in electric field in the undoped GaSb layer of Van Hoof structures. The electric field was determined using the standard approach to analyze the Franz-Keldysh oscillations (FKO). Similar approach was also used recently by us and others to determine electrical field in different material systems.

GaSb Van Hoof structures of various thicknesses of undoped GaSb top layer (20, 40, and 60 nm) were grown by solid-source molecular beam epitaxy (MBE) in a Varian Gen. II system equipped with a Veeco Mark-IV valved-cracker for antimony and Veeco SUMO effusion cells for gallium and indium. The nominally undoped top layer is p-type with the hole concentration $p < 10^{17}$ cm$^{-3}$. Beryllium and tellurium were used as the p-type and n-type dopant, respectively. The n-type (3 × 10$^{18}$ cm$^{-3}$) Van Hoof structures were grown on tellurium-doped (100) (1–9 × 10$^{17}$ cm$^{-3}$) GaSb substrates while the p-type (3 × 10$^{17}$ cm$^{-3}$) Van Hoof structures were grown on unintentionally doped (100) (p-type, 1–9 × 10$^{17}$ cm$^{-3}$) GaSb substrates. All samples were grown at a substrate temperature of 460 °C, as measured using a pyrometer. Figure 1 shows schematically the layer sequences in the GaSb Van Hoof structure.

For the CER measurements, the samples were mounted in a capacitor with the top electrode made from a copper wire mesh which is semi-transparent to light. This electrode was kept at a distance of ~0.5 mm from the sample surface, while the sample itself was fixed on the bottom copper electrode. A maximum peak-to-peak alternating voltage of ~3.0 kV at a frequency of 285 Hz was applied. Other...
III. RESULTS AND DISCUSSION

Figure 2 shows room temperature CER spectra for the two sets of GaSb Van Hoof structures. Because of the shallow probing depth of the CER technique and the architecture of the Van Hoof structures, the entire CER signal can be attributed to the electric field in undoped GaSb layer. CER resonance related to the absorption edge at the energy gap of GaSb is clearly observed at ~0.724 eV. This resonance is followed by FKO. The period of the FKO is used to estimate built-in electric field. It is assumed that this field is homogeneous since the depletion layer of undoped GaSb is much larger than the thickness of the undoped layer in our samples and, therefore, the built-in electric field in the top GaSb layer is determined from the Fermi level pinning at GaSb surface and the Fermi level position in the doped GaSb layer which is at the edge of the conduction (valence) band for n-type (p-type) structures. A decrease of the built-in electric field is expected when the thickness of the undoped layer is increased. This decrease is clearly observed in Fig. 2 as a shortening of the FKO period. It is worth noting that the whole FKO can be attributed to the optical transitions between the heavy-hole and electron subband. A contribution of light-hole related signal is also expected in CER spectra but its intensity is much weaker and therefore it does not affect the position of FKO extrema. In some samples, the light-hole contribution cannot be neglected especially when more than six FKO extrema are observed, see, for example, Refs. 12 and 13, but for samples studied in this paper only four FKO extrema are analyzed and therefore the light-hole contribution can be neglected.

A conventional method to determine the built-in electric field from the period of FKO is to use an asymptotic expression for the electro-reflectance

\[
\frac{\Delta R}{R} \propto \exp \left[ \frac{-2 \Gamma \sqrt{E - E_g}}{(h\theta)^{1/2}} \right] \cdot \cos \left[ \frac{4}{3} \left( \frac{E - E_g}{h\theta} \right)^{3/2} + \varphi \right]
\]

\[
(h\theta)^3 = \frac{e^2 h^2 F^2}{2 \mu},
\]

where \( h\theta \) is the electro-optic energy, \( \Gamma \) is the linewidth, \( \varphi \) is an angle, \( F \) is the electric field, and \( \mu \) is the electron-hole reduced mass which is assumed to be 0.04 \( m_0 \) after Refs. 1 and 23. The extrema of the FKO are given by

\[
n\pi = \varphi + \frac{4}{3} \left( \frac{(E_n - E_g)}{h\theta} \right)^{3/2},
\]

where \( n \) is the index of the \( n \)-th extremum and \( E_n \) is the corresponding energy. A plot of \( (E_n - E_g)^{3/2} \) versus \( n \) yields a straight line with a slope proportional to \( F \).

Figure 3 shows the analysis of the GaSb-related FKO period for the n-type (open points) and p-type (solid points) GaSb Van Hoof structures. Built-in electric fields of 212, 123, and 92 kV/cm were determined for the n-type structures with 20, 40, and 60 nm thick undoped layer, respectively. Much smaller built-in electric fields were found for p-type structures. For the structure with 40 nm thick layer, the field was 54 kV/cm. For p-type structure with 60 nm thick undoped GaSb layer, the built-in electric field was smaller and, therefore, the FKO feature was not clearly observed in CER spectrum. In this case, the CER resonance gives a very good estimate of the GaSb bandgap.

To determine the Fermi-level position at the GaSb surface, the obtained built-in electric fields are plotted in Fig. 4.
and fitted by the formula $F = \Phi/d$, with the surface potential barrier $\Phi$ treated as a fitting parameter. The best fit for n-type structures was found to be $\Phi = 0.50 \pm 0.05$ eV. The fitting curve is shown by the thick black line in Fig. 4, along with two additional curves corresponding to $\Phi = 0.55$ eV (dashed line) and $\Phi = 0.45$ eV (short dashed line), for a better visualization of the influence of experimental uncertainties on this analysis. In addition, the built-in electric field was also calculated for p-type structures, with the surface potential determined for n-type structures and plotted by grey lines in Fig. 4.

The surface Fermi level pinning position for GaSb determined using CER agrees very well with the studies of Folkes et al. Measuring magnetotransport characteristics for GaSb-InAs-AlSb heterostructures, the authors concluded that the Fermi level is pinned around 0.2 eV above the top of the GaSb valence band when the GaSb cap layer width is greater than 90 nm. For metal/GaSb interface, the Fermi level is located close to the valence band and hence a large n-type Schottky barrier is formed for GaSb structures. We believe that the formation of large n-type Schottky barrier for (100) GaSb surface is associated with the intrinsic Fermi level pinning on this surface. It is worth noting that the Fermi level pinning position on (100) GaSb surface is associated with the intrinsic Fermi level pinning on heavily damaged materials, which is known to be located at the so-called “Fermi level stabilization energy” situated ~4.9 eV below the vacuum level. This suggests that dangling bond like defects tend to stabilize the surface Fermi level at the same energy as in heavily damaged GaSb.

IV. CONCLUSIONS

In conclusion, the Fermi level pinning position on (100) GaSb surface was studied using MBE grown n-type and p-type Van Hoof structures. It has been found that the Fermi level is pinned ~0.2 eV above the valence band for both n-type and p-type structures. From the fit of experimental data obtained for the series of n-type structures, the surface potential barrier has been determined to be $0.50 \pm 0.05$ eV.

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